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APPLICANTS

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** CONTINUING DATA *****

BK, now 8

** FOREIGN APPLICATIONS *****

BK, now 8

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature <u>BK</u> Initials	STATE OR COUNTRY CA	SHEETS DRAWING 4	TOTAL CLAIMS 17	INDEPENDENT CLAIMS 1
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ADDRESS

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TITLE

Method of controlling critical dimension microloading of photoresist trimming process by selective sidewall polymer deposition

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